

2815



Attorney Docket No. 0756-2256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 09/774,637

Filed: February 1, 2001

For: BEAM HOMOGENIZER LASER

IRRADIATION APPARATUS,

SEMICONDUCTOR DEVICE, AND

METHOD OF FABRICATING THE

SEMICONDUCTOR DEVICE

) Group Art Unit: 2815

) Examiner: J. Diaz

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

10.20.03

Adeline M. Stamps

#14/10
10/27/03
Jemo

TECHNOLOGY CENTER 2800

OCT 23 2003

RECEIVED

AMENDMENT

Honorable Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated July 18, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.